

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88662

Takenori OSADA, et al.

Appln. No.: 10/540,513

Group Art Unit: 2893

Confirmation No.: 6641

Examiner: Eduardo A. RODELA

Filed: June 23, 2005

For: COMPOUND SEMICONDUCTOR EPITAXIAL SUBSTRATE AND METHOD FOR
MANUFACTURING THE SAME

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on
October 29, 2009:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was sent on November 2, 2009.

During the interview, the following was discussed:

1. Brief description of exhibits or demonstration: N/A
2. Identification of claims discussed: All pending
3. Identification of art discussed: Tanimoto
4. Identification of principal proposed amendments: N/A
5. Brief Identification of principal arguments: Applicants' representative discussed the strain channel and the previously-submitted Rule 1.132 Declaration.

6. Indication of other pertinent matters discussed: N/A

7. Results of Interview: The Examiner indicated that he would consider the Amendment.

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,

/ Travis B. Ribar /

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: April 9, 2010

Travis B. Ribar
Registration No. 61,446